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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of

Shunichi SEKI et al.

Group Art Unit: 2811

Application No.: 10/686,634

Filed: October 17, 2003

Docket No.: 104741.01

For: METHOD OF FORMING THIN FILM PATTERNING SUBSTRATE INCLUDING
FORMATION OF BANKS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The references were cited in a counterpart foreign application.
- ☒ 3. The present application was filed or entered the U.S. National Stage of the PCT after June 30, 2003. In accordance with the June 11, 2003, Notice waiving the requirements of 37 CFR §1.98(a)(2)(i), copies of any U.S. patents and patent application publications are not attached.

- ☒ 4. English-language Abstracts of the non-English language references are attached hereto.

Respectfully submitted,



James A. Oliff
Registration No. 27,075

Klifton L. Kime
Registration No. 42,733

JAO:KLK/kzb

Date: August 19, 2004

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

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Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce TRADEMARK OFFICE PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 104741.01		APPLICATION NO. 10/686,634	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT(S) Shunichi SEKI et al.			
				FILING DATE October 17, 2003		GROUP 2811	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
	1	5,948,577	09/07/1999	Nakazawa et al.			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
	2	JP 61-245106 w/Abstract	10/31/1986	Japan			
	3	JP 62-109002 w/Abstract	05/20/1987	Japan			
	4	JP 04-121702 w/Abstract	04/22/1992	Japan			
	5	JP 09-015412 w/English translation	01/17/1997	Japan			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: August 19, 2004